



PATENT

Atty. Dkt. No. AMAT/4227.P1/DSM/BCVD/JW

1752

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Latchford, et al.

Serial No.: 09/921,938

Confirmation No.: 8367

Filed: August 2, 2001

For: Photolithography Scheme
Using a Silicon Containing
Resist

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Group Art Unit: 1752

Examiner: Amanda C. Walke

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MAY 22 2003
GROUP 1700

13/12

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING
37 CFR 1.8

I hereby certify that this correspondence is being deposited on
May 15, 2003, with the United States Postal Service as First
Class Mail in an envelope addressed to: Mail Stop Non-Fee
Amendment, Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450

05/15/2003
Date

Bm. Jh
Signature

RESPONSE TO OFFICE ACTION DATED FEBRUARY 26, 2003

In response to the Office Action dated February 26, 2003, having a shortened statutory period for response set to expire on May 26, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no fee is due in conjunction with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/4227.P1/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

IN THE CLAIMS:

Please cancel claims 16 and 18, without prejudice, and amend the claims as follows: